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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

: Confirmation No. 8916

Hiroshi SOTOZAKI et al.

: Attorney Docket No. 2004\_0208

Serial No. 10/774,489

: Group Art Unit 1763

Filed February 10, 2004

: Examiner Sylvia MacArthur

METHOD AND APPARATUS FOR  
POLISHING A SUBSTRATE

: Mail Stop: AF

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AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

Responsive to the Office Action mailed September 26, 2005, please amend the above-identified application as follows: